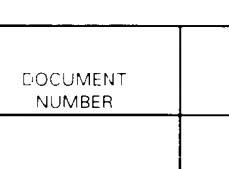


FORM PTO 1449 (modified) U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) <i>(Use several sheets if necessary)</i>			ATTY DOCKET NO.	APPLICATION NO.		
			35.G2738	09/749,727		
			APPLICANT YOICHI ANDO			
FILING DATE December 28, 2000			GROUP	N.Y.A.		
U. S. PATENT DOCUMENTS						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	FILING DATE IF APPROPRIATE
						
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	TRANSLATION YES NO OR ABSTRACT
						
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)						
<i>EJG</i>		M. Hartwell et al.; "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films"; INTERNATIONAL ELECTRON DEVICES MEETING; 1975, pp. 519-521.				
<i>EJG</i>		G. Dittmer; "Electrical Conduction and Electron Emission of Discontinuous Thin Films"; THIN SOLID FILMS; 1972, pp. 317-328.				
<i>EJG</i>		C.A. Mead; "Operation of Tunnel-Emission Devices"; JOURNAL OF APPLIED PHYSICS; Vol. 32, January-December 1961, pp. 646-652.				
<i>EJG</i>		W.P. Dyke et al.; "Field Emission"; ADVANCES IN ELECTRONICS AND ELECTRON PHYSICS; Vol. VIII, 1956, pp. 89-185.				
<i>EJG</i>		C.A. Spindt et al.; "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones"; JOURNAL OF APPLIED PHYSICS; Vol. 47, No. 12, December 1976, pp. 5248-5263.				
<i>EJG</i>		H. Araki et al.; "Electroforming and Electron Emission of Carbon Thin Films"; J. Vac. Soc. Japan, 26 (1983), pp. 22-29; (with English Abstracts on p. 22).				
<i>EJG</i>		M.L. Elinson et al.; "The Emission of Hot Electrons and the Field Emission of Electrons from Tin Oxide"; RADIO ENGINEERING AND ELECTRONIC PHYSICS; July 1965, pp. 1290-1296.				
EXAMINER	<i>EJG</i>		DATE CONSIDERED		1-25-03	

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U. S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>mg</i>		5,532,548	7/96	Spindt et al.	313	422	
<i>mg</i>		5,770,918	6/98	Kawate et al.	313	495	
<i>mg</i>		5,903,108	5/99	Mougin et al.	315	169.1	
<i>mg</i>		6,114,804	9/00	Kawase et al.	313	495	
<i>mg</i> P E MAR 15 2001		6,053,791	4/00	Fujii et al.	445	6	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<i>mg</i>		0 865 069	9/16/98	EPO			
<i>mg</i>		0 866 490	9/23/98	EPO			
<i>mg</i>	WO	98/28774	7/2/98	PCT			
<i>mg</i>	WO	99/03126	1/21/99	PCT			
<i>mg</i>		1-241742	9/26/89	Japan			Abstract
<i>mg</i>		4-94038	3/26/92	Japan			Abstract
<i>mg</i>		4-98744	3/3/92	Japan			Abstract
<i>mg</i>		04-163833	6/9/92	Japan			Abstract
<i>mg</i>		4-284340	10/8/92	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER <i>Steven J. Zimmerman</i>			DATE CONSIDERED <i>1-29-03</i>				

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